

Application/Control No.	Applicant(s)/Patent und Reexamination	ier
10/766,736	TAKIZAWA ET AL.	
Examiner	Art Unit	
Kevin P. Kerns	1725	

	0545	OUED.				
	SEARCHED					
Class	Subclass	Date	Examiner			
164	113, 312, 900	5/16/2005	KPK			
EAST	update	10/25/05	KPK			
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
164	113, 312,	10/25/05	KPK	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
inventor search & referred to parent application 09/740,513 (now US 6,866,088) for double patenting	5/16/2005	КРК
update inventor search	10/25/05	KPK
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